

PATENT

Attorney Docket No. MTI-31532

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Weimer, Ronald A.
Serial No. : 09/941,827
Filing Date : August 29, 2001
For : Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices
Examiner : HUYNH, Yennhu B.
Group Art Unit : 2813
Confirmation No. : 7551

CERTIFICATION UNDER 37 CFR 1.8(a) and 1.10

I hereby certify that, on the date shown below, this correspondence is being:

Mailing

- ☒ deposited with the United States Postal Service in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231
37 CFR 1.8(a) 37 CFR 1.10
☐ with sufficient postage as first class mail ☒ As "Express Mail Post Office to Addressee" Mailing Label No. EX 326236245 US

Transmission

- ☐ transmitted by facsimile to Fax No. _____ addressed to Examiner _____ at the U.S. Patent and Trademark Office.

Date: Sept 4, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL1. Transmitted herewith is:

- Response
- Copy of previously submitted Information Disclosure Statement and Form 1449/PTO.
- Return Postcard

STATUS

2. Applicant is a large entity.

DOCKET BY BS 9/4/03CDC BY BS response QA 9/4/03
12/4/03 cd

MKE/808107.1